

DIAGNOSIS METHOD AND DIAGNOSIS SYSTEM FOR  
MONITORING THE AVAILABLE RESOURCES  
IN A PRODUCTION PROCESS  
DAFERNER, et al.  
PCT No.: PCT/EP00/0500  
Attorney Docket No. 225/50818  
Sheet 1 of 3

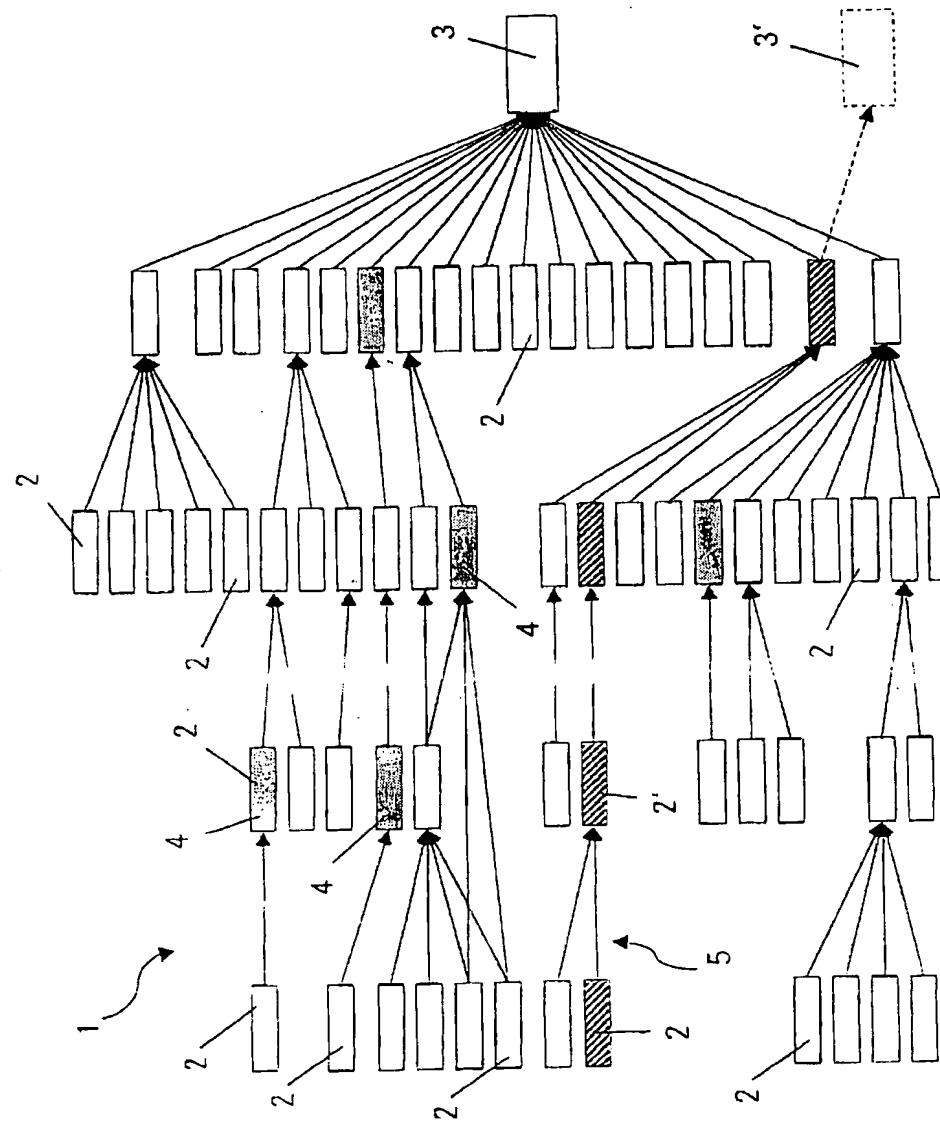


Figure 1

DIAGNOSIS METHOD AND DIAGNOSIS SYSTEM FOR  
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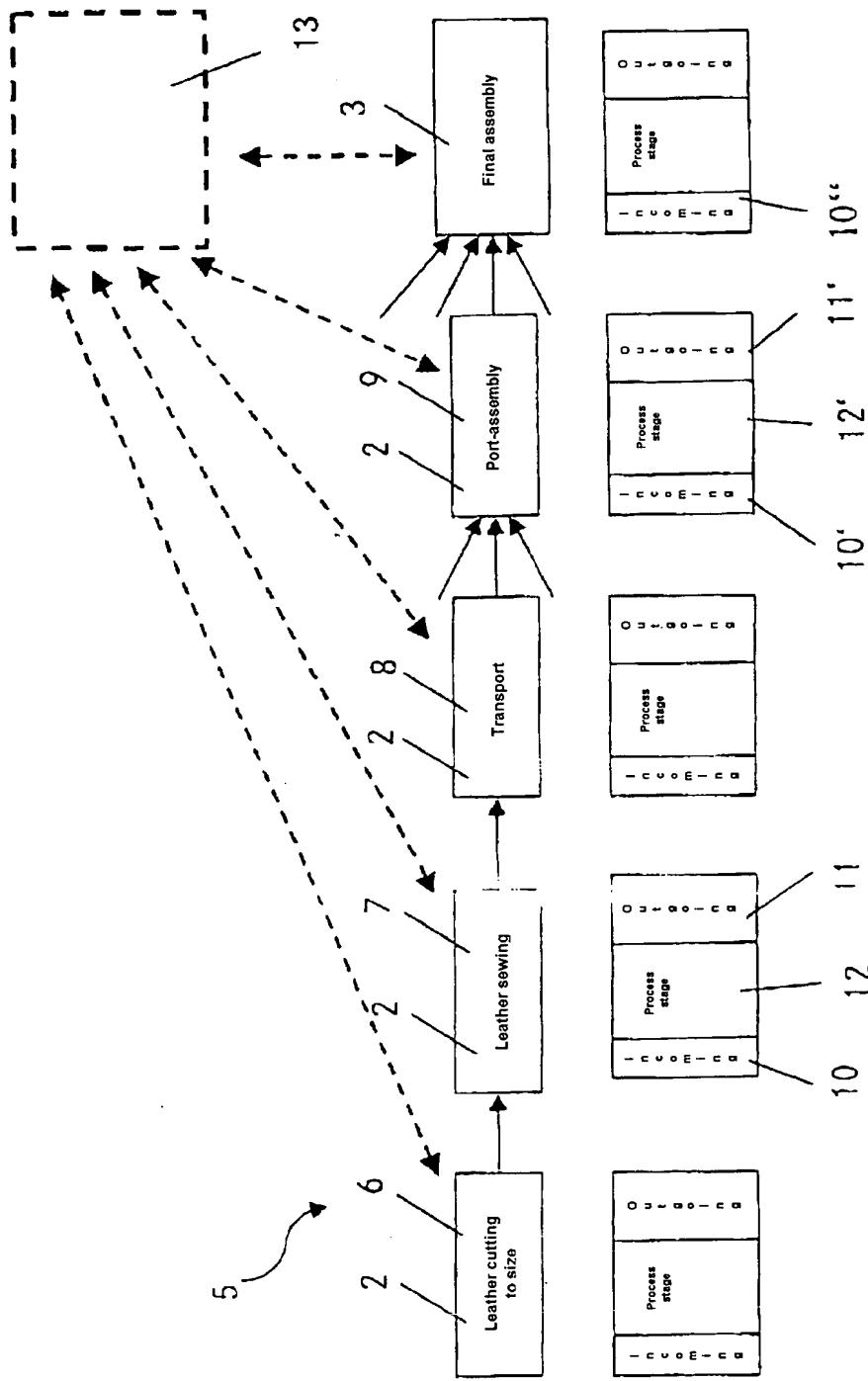


Figure 2

DIAGNOSIS METHOD AND DIAGNOSIS SYSTEM FOR  
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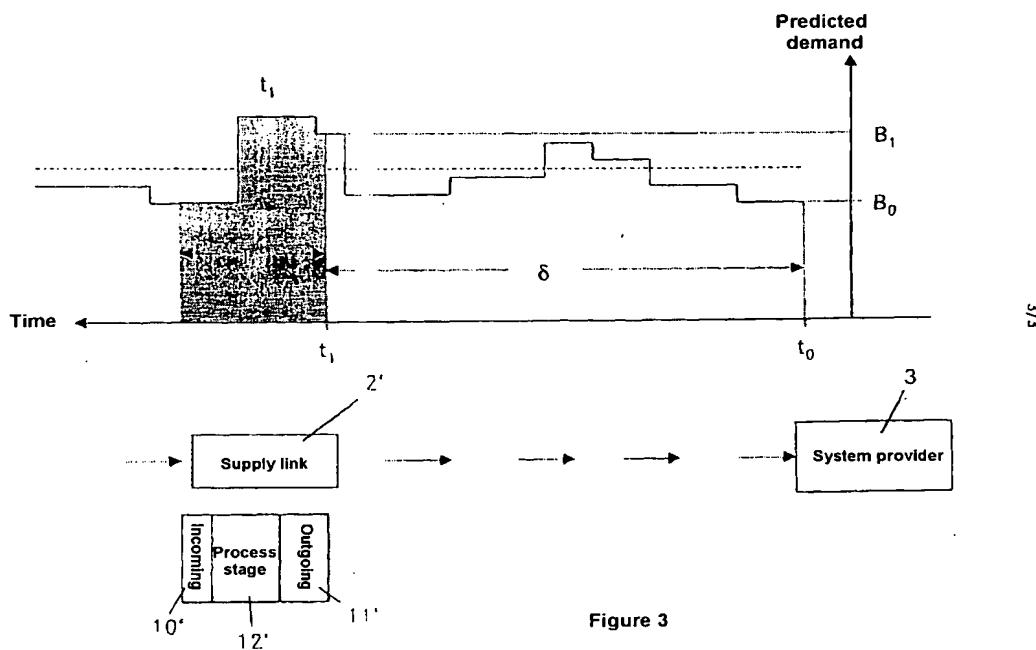


Figure 3